

Form PTO 1449 (REV. 7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO.: 645-145		SERIAL NO.: 09/872,842	
LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Akira Masumura			
				FILING DATE: June 1, 2001		GROUP: 1755	
U.S. PATENT DOCUMENTS							
EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NAME	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
OKS	AL	08 104538	4-23-1996	Japan			no
	AM	60 200842	10-11-1985	Japan			no
	AN	60 077144	5-1-1985	Japan			no
	AO	08 283038	10-29-1996	Japan			no
OKS	AP	06 135739	5-17-1994	Japan			no
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)							
OKS	AR	Westerhoff T et al., "Optical materials for microlithography applications", INORGANIC OPTICAL MATERIALS, SAN DIEGO CA, USA, 19-20 July 1998, vol. 3424, pages 10-19, The International Society for Optical Engineering, *page 10 paragraph 1- page 13, paragraph 1*					
		EP Search Report					
	AS						
	AT						
EXAMINER:		DATE CONSIDERED:		3/10/03			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO 1449 (REV. 7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO.: 645-145		SERIAL NO.: 09/872,842		
LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Akira Masumura				
				FILING DATE: June 1, 2001		GROUP: -- 1755		
U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
FOREIGN PATENT DOCUMENTS								
		DOCUMENT NAME	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO	
	AL	04 055337	2-24-1992	Japan			no	
	AM							
	AN							
	AO							
	AP							
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AR							
	AS							
	AT							
EXAMINER:				DATE CONSIDERED: 3/10/03				
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>								